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AND NANOSYSTEMS (MNS 2020)**

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## CONTENTS

### 14TH INTERNATIONAL CONFERENCE ON MICRO- AND NANOSYSTEMS (MNS 2020)

#### BIO MEMS/NEMS

**DETC2020-22022..... V001T01A001**

Non-Enzymatic and Electrodeless Detection of Direct Bilirubin Using Metal Enhanced Fluorescence Effect

*Cheng-Yi Li, Chang-I Peng, Sandy Huey-Jen Hsu, Cheng-Chung Chang, Gou-Jen Wang*

**DETC2020-22185..... V001T01A002**

Development of a MEMS Chemical Sensor for Detection of Phthalates in Juice Using Electrochemical Impedance Spectroscopy

*Nadia Ebrahimpour Tolouei, Md Ebrahim Khalil Bhuiyan, Michael Hankins, Mohammad Shavezipur*

**DETC2020-22207..... V001T01A003**

Investigation of the Effect of Native Oxide Layer on Performance of Interdigitated Impedance-Based Silicon Biochemical Sensors

*Nadia Ebrahimpour Tolouei, Shima Ghamari, Mohammad Shavezipur*

**DETC2020-22229..... V001T01A004**

Bio-MEMS Circular Plate Sensors Under Electrostatic Hard Excitations: Frequency Response of Superharmonic Resonance of Fourth Order

*Julio Beatriz, Dumitru I. Caruntu*

**DETC2020-22391..... V001T01A005**

316L Stainless Steel Sensitization in Carbon Nanotube CVD Growth for Bacterial Resistance

*Sterling Voss, Bret Mecham, Lucy Bowden, Jacquelyn Monroe, Anton E. Bowden, Brian D. Jensen*

#### DYNAMICS OF MEMS AND NEMS

**DETC2020-22050..... V001T01A006**

Investigation of 3:1 Internal Resonance of Electrostatically Actuated Microbeams With Flexible Supports

*Praveen Kumar, Mandar M. Inamdar, Dnyanesh N. Pawaskar*

#### FLEXIBLE MEMS/NEMS

**DETC2020-22721..... V001T01A007**

Design and Simulations of a Novel Stiction-Free Laterally Actuated NEM Relay With Flexible Source-Drain Contact

*Mehrdad Zandigohar, Mohammad Shavezipur*

## FUNCTIONAL MATERIALS AND SURFACE ENGINEERING

**DETC2020-22158**..... **V001T01A008**

Two-Phase Thermal Metamaterial  
*Zifu Xu, Longqiu Li, Jiaxin Li*

**DETC2020-22274**..... **V001T01A009**

Unidirectional Acoustic Parametric Amplification in Space-Time Modulated Membrane System  
*Xiaohui Zhu, Longqiu Li, Guangyu Zhang*

## MEMS SENSORS AND ACTUATORS

**DETC2020-22210**..... **V001T01A010**

Linearization of Characteristic Response of a Capacitive MEMS Pressure Sensor by Patterning the Dielectric Layer  
*Nadia Ebrahimpour Tolouei, Mohammad Shavezipur*

**DETC2020-22497**..... **V001T01A011**

Improving Linearity of Circular Capacitive Pressure Sensor by Using a Dimple Mask  
*Md Ebrahim Khalil Bhuiyan, Mohammad Shavezipur*

**DETC2020-22586**..... **V001T01A012**

2:1 MUX and OR Logic Functions Using Triple Partial Electrodes: Toward Cascadable MEMS Logic Devices  
*Sherif A. Tella, Mohammad I. Younis*

**DETC2020-22604**..... **V001T01A013**

Organic Piezoresistive Pressure Sensitive Robotic Skin for Physical Human-Robot Interaction  
*Danming Wei, Ruoshi Zhang, Mohammad N. Saadatzi, Olalekan O. Olowo, Dan O. Popa*

## MEMS/NEMS NEURAL AND DIGITAL COMPUTING

**DETC2020-22594**..... **V001T01A014**

Multi-Inputs/Outputs and Cascadable MEMS Resonator-Based Computing Devices  
*Sherif A. Tella, Mohammad I. Younis*

**DETC2020-22665**..... **V001T01A015**

Machine Learning Augmentation in Micro-Sensor Assemblies  
*Mohammad H. Hasan, Fadi Alsaleem, Amin Abbasalipour, Siavash Pourkamali Anaraki, Muhammad Emad-Un-Din, Roozbeh Jafari*

**DETC2020-22671**..... **V001T01A016**

Nonlinear Time-Series Prediction Using a Single MEMS Reservoir  
*Mohammad H. Hasan, Fadi Alsaleem*

## MICRO/NANO ROBOTICS AND MANUFACTURING

**DETC2020-22061**..... **V001T01A017**

Kinematic Design of Functional Nanoscale Mechanisms From Molecular Primitives  
*Pouya Tavousi, Meysam T. Chorsi, Caitlyn Mundrane, Vitaliy Gorbatyuk, Kazem Kazerounian, Horea Ilies*

**DETC2020-22415**..... **V001T01A018**

Experimental Investigation of Microfluidic Feature Manufacturing by Digital Light Processing Stereolithography  
*Lara Rebaioli, Irene Fassi*

**DETC2020-22476**..... **V001T01A019**

Rapid Fabrication of POM Flexure Hinges via a Combined Injection Molding and Stereolithography Approach  
*Marcello Valori, Rossella Surace, Vito Basile, Luca Luzi, Rocco Vertechy, Irene Fassi*